



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 27, 2026

IGI Report Number

LG808606207

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MARQUISE ROSE CUT

Measurements

9.33 X 5.53 X 2.35 MM

GRADING RESULTS

Carat Weight

1.04 CARAT

Color Grade

E

Clarity Grade

VS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

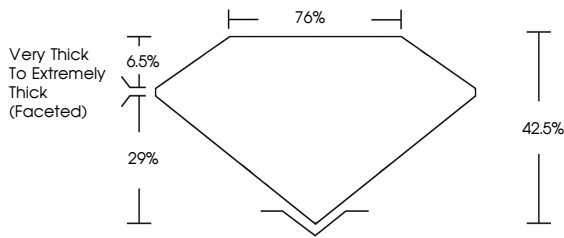
Inscription(s)

 LG808606207

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



Very Thick To Extremely Thick (Faceted)

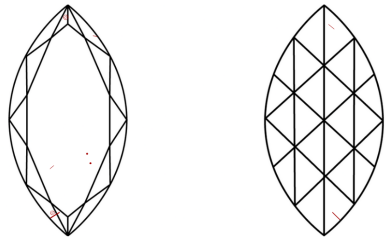
76%

6.5%

29%

42.5%

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used



COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

LABORATORY GROWN DIAMOND REPORT



July 27, 2026

IGI Report Number

LG808606207

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MARQUISE ROSE CUT

Measurements

9.33 X 5.53 X 2.35 MM

GRADING RESULTS

Carat Weight

1.04 CARAT

Color Grade

E

Clarity Grade

VS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

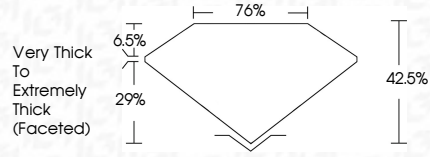
Fluorescence

NONE

Inscription(s)

 LG808606207

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa



Very Thick To Extremely Thick (Faceted)

76%

6.5%

29%

42.5%



IGI



© IGI 2020, International Gemological Institute

FD - 10 20

July 27, 2026

IGI Report No LG808606207

MARQUISE ROSE CUT

9.33 X 5.53 X 2.35 MM

1.04 CARAT

E

Color Grade

VS 2

42.5%

76%

Very Thick To Extremely Thick (Faceted)

EXCELLENT

EXCELLENT

NONE

 LG808606207

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa